INFORMATION DISCLOSURES Atty. Docket No.: 1000.06-US Serial No.: 09/645,827 Applicant: Flanders, et al. Group: 1756 DEC 0 3 2001 Filing Date: 8/25/2000 Examiner: Unknown MADRIARY U.S. PATENT DOCUMENTS Examiner Document Filing Date if **Initial** Number Date Name Class Subclass appropriate 4,528,747 AA07/16/1985 Hoffman, et al. 29 834 ABAC AD AE AF FOREIGN PATENT DOCUMENTS Document Translation Number Date Country Class Subclass Yes No 91/06022 AG. 02 May 1991 WO G02B 6/36 AH 40 647 091 05 APR 1995 EP H05K 13/04 ΑI OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.) Knight, J. Douglas; and West, Joseph N., "A Two-Axis Micropositioner for Optical Fiber Alignment," Hewlett-Packard Journal, 44 (1993) December, No. 6, Palo Alto, CA US. ΑJ AK AL **AM** AN Examiner Date Considered

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